

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	(electrostatic adj4 (chuck or clamp\$4)) and electrode near5 ((metal adj3 (pade or terminal)) near5 (Al or aluminium))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/30 08:27
L2	727	(electrostatic adj4 (chuck or clamp\$4)) and (electrode near7 (Al or aluminium))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/30 08:30
L3	110114	2 and "355"/\$.ccls. or "361"/\$.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/30 08:31
L4	152	2 and ("355"/\$.ccls. or "361"/\$.ccls.)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/30 08:32
L5	126	4 and dielectric	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/30 08:35
L6	0	4 and (dielectric near6 (Si adj2 (layer)))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/30 08:35
L7	0	4 and (dielectric near6 ((Si or silicon) adj2 (layer)))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/30 08:36
L8	19	4 and (dielectric near6 (Si or silicon))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/30 08:39
L9	3	8 and (lithograph\$4 or exposure)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/30 08:59
L10	46	5 and (lithograph\$4 or exposure or microlithograph\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/30 08:42

L11	9	5 and (lithograph\$4 or microlithograph\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/30 08:42
L12	66051	(lithographic or microlithograph\$4) or (exposure same (mask or reticle or substrate or wafer)) and electrostatic adj3 (chuck or clamp\$)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/30 09:00
L13	43634	12 and (wafer or substrate or mask or reticle)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/30 09:00
L14	7349	13 and ((dielectric or isolat\$4) adj2 (layer))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/30 09:01
L15	3904	14 and electrode	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/30 09:01
L16	3572	15 and lithograph\$4	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/30 09:01
L17	3236	16 and (dielectric adj3 (layer))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/30 09:02
L18	130	17 and (electrostatic adj3 (chuck or clamp\$4))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/30 10:09
L19	62	18 and (dielectric adj3 constant)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/30 10:09